UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO. : 7,318,903 B2 Page 1 of 2

APPLICATION NO. : 10/567917 DATED : January 15, 2008

INVENTOR(S) : Jamie R. Link and Michael J. Sailor

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Claim 1	Col. 7, line 26 Col. 7, line 27 Col. 7, line 29 Col. 7, line 32	Please delete "silicon" Please delete "silicon" Please delete "dielectric mirror" and insertpatterned layer therefor Please delete "to a second patterned layer"
Claim 2	Col. 7, line 42	Please delete "silicon"
Claim 4	Col. 7, line 46 Col. 7, line 47	Please delete "dielectric" and insertpatterned therefor Please delete "mirror" and insertlayer therefor
Claim 7	Col. 7, line 54	Please delete "silicon"
Claim 8	Col. 7, line 57	Please delete "silicon"
Claim 12	Col. 8, line 4	Please delete "silicon"
Claim 13	Col. 8, line 6 Col. 8, line 9 Col. 8, line 11	Please delete "(10) of porous silicon" and insertof porous material therefor Please delete "(12)" Please delete "(14)"
Claim 16	Col. 8, line 21 Col. 8, line 22 Col. 8, line 27 Col. 8, line 28 Col. 8, line 29	Please delete "(10)" Please delete "silicon" and insertmaterial-therefor Please delete "silicon particles (10)" and insertparticles therefor Please delete "(12)" Please delete "(14)"

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Claim 21 Col. 8, line 43 Please delete "(12,14)"

Col. 8, line 44 Please delete "silicon" Col. 8, line 50 Please delete "silicon"

Signed and Sealed this

Seventeenth Day of June, 2008

JON W. DUDAS
Director of the United States Patent and Trademark Office